

Helium Replacement in Italy - HeRe in Italy

Tuesday 03 December 2013

Deposizione e caratterizzazione di film sottili - Aula B. Brunelli (09:00-11:00)

-Conveners: Rosa Maria Montereali

time	[id] title	presenter
09:00	[17] Thin film depositions: the ion plating technique	MISIANO, C.
09:20	[18] Boron deposition by electron beam technique	CELENTANO, G.
09:40	[19] Thin film deposition and characterization at Optical coating Lab at ENEA Casaccia	SYTCHKOVA, A.
10:00	[20] Focused Ion-Beam and nano-mechanical tests for surface and sub-surface, high spatial resolution characterization	BEMPORAD, E.
10:20	[21] XPS spectroscopy of low atomic number elements: B thin films on Al ₂ O ₃ substrates	SANTONI, A.
10:40	[22] Chemical characterization of thin films: focus on ICP-MS and laser ablation techniques	ZAPPA, G.